FORM PTO 1449 (*modified*) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE LIST OF REFERENCES CITED BY APPLICANT(S) (*Use several sheets if necessary*)	ATTY DOCKET NO. 03500.010106.5	APPLICATION NO. NOT YET ASSIGNED
	APPLICANT TOSHIKAZU OHNISHI ET AL.	
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U.S. PATENT DOCUMENTS

*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		6,348,761 B1	2/02	Nomura et al.	313	495	6/94
		4,949,019	8/90	Isaka et al.	445	6	
		5,066,883	11/91	Yoshioka et al.	313	309	
		5,006,883	11/91	Yoshioka et al.	313	309	
		4,954,744	9/90	Suzuki et al.	313	336X	
		5,285,129	2/94	Takeda et al.	313	309X	
		5,256,936	10/93	Itoh et al.	313	309X	
		5,141,460	8/92	Jaskie et al.	313	309X	

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
		0523702A1	1/93	EPO			Abstract
		1283749A	11/89	JAPAN			Abstract
		A1309242	12/89	JAPAN			No
		536731A1	4/93	EPO			
		1-309242	12/89	JAPAN			Translation
		0 299 461	1/89	EPO			

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		OTHER DOCUMENT(S) (*Including Author, Title, Date, Pertinent Pages, Etc.*)
		"Metal Influence on Switching MIM Diodes", H. Pagnia, et al., Phys. Stat. Sol. (a), 111, 387 (1989)
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		OTHER DOCUMENT(S) (*Including Author, Title, Date, Pertinent Pages, Etc.*)
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